

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Philippe ROBERT et al.

Application No.: New U.S. National Stage of
PCT/FR03/003789

Filed: May 27, 2005

Docket No.: 124102

For: PRODUCTION PROCESS OF A FLAT SUSPENDED MICRO-STRUCTURE USING A
SACRIFICIAL LAYER OF POLYMER MATERIAL AND COMPONENT OBTAINED
THEREBYINFORMATION DISCLOSURE STATEMENTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information.
- ☒ 3. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.

Respectfully submitted,

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WPB:EDM/crh

Date: May 27, 2005

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 124102		APPLICATION NO. New U.S. National Stage of PCT/FR03/003789	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Philippe ROBERT et al.			
				FILING DATE May 27, 2005			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
	1	US 2002/0047172 A1	04/25/2002	Reid			
	2	5,582,678	12/10/1996	Komuro			
	3	5,430,421	07/04/1995	Bornand et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	4	WO 02/068321 A2	09/06/2002	WIPO			
	5	WO 00/33089 A2	06/08/2000	WIPO			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	6	Song et al.; "Wafer Level Vacuum Packaged De-Coupled Vertical Gyroscope By a New Fabrication Process";					
		Proceedings of the IEEE 13 th Annual International Conference on Micro Electro Mechanical Systems; pp. 520-524;					
		XP010377181; January 23, 2000					
EXAMINER				DATE CONSIDERED			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: May 27, 2005